


<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>		<b>Attorney Docket No.</b> 13DV-13711	<b>Application No.</b> 10/063,808
<b>Submitted by:</b> 		<b>Applicant:</b> Ramgopal Darolia, et al	
Domenica N.S. Hartman, Reg. No. 32,701		<b>Filing Date:</b> 05/15/03	<b>Group Art No.</b> 1753

## U.S. PATENT DOCUMENTS


Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date if appropriate
SHV	4,403,002	09/06/83	Akashi, et al	427	255.5	
SHV	5,296,274	03/22/94	Movchan, et al	427	566	

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SEP 10 2003  
TC 1700

## FOREIGN PATENT DOCUMENTS

Examiner's Initials	Document Number	Date	Country	Class	Subclass	Translation Yes   No
	JP05156438	06/22/93	Japan	C23C	14/54	
	JP06322521	11/22/94	Japan	C23C	14/06	
SHV	EP1008669	06/14/00	Europe	C23C	14/30	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


Examiner	
Date Considered	March 15, 2004

\*Examiner: Initial if reference considered whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.



# Electronic Information Disclosure Statement

## PHYSICAL VAPOR DEPOSITION APPARATUS AND PROCESS

Application:   
10/063808  
Confirmation: 4319  
Applicant(s): Ramgopal Darolia  
Docket Number: 13DV-13711  
Group Art Unit: 1762  
Examiner:  
search string: (6007880).pn.


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### US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
SM	P01	6007880	1999-12-28		Maloney	427	585

### Signature

Examiner Name	Date
	March 15, 2004